

Day: Thursday Date: 5/18/2006 Time: 12:48:38

Inventor Name Search Result

Your Search was:

Last Name = CHEN

First Name = CHIA-CHEN

Application#	Patent#	Status	Date Filed	Title	Inventor Name	
09189119	6346456	150	11/09/1998	METHOD OF IMPROVING ALIGNMENT FOR SEMICONDUCTOR FABRICATION	CHEN, CHIA-CHEN	
<u>09191306</u>	6080659	150	11/13/1998	METHOD TO FORM AN ALIGNMENT MARK	CHEN, CHIA-CHEN	
09208286	Not Issued	161	12/08/1998	ALIGNMENT-MARK STRUCTURE WITH PROTECTIVE DUMMY PATTERN FOR SEMICONDUCTOR FABRICATION	CHEN, CHIA-CHEN	
09222740	Not Issued	161	12/29/1998	METHOD OF MULTI-STEP CHEMICAL-MECHANICAL POLISHING	CHEN, CHIA-CHEN	
10373099	Not Issued	41	02/26/2003	Method for shrinking pattern photoresist	CHEN, CHIA-CHEN	
10623646	Not Issued	30		Method of reconstructing a regular 3D model by feature-line segmentation	CHEN, CHIA-CHEN	
10626698	Not Issued	61	07/25/2003	Multilevel texture processing method for mapping multiple images onto 3D models	CHEN, CHIA-CHEN	
10717603	Not Issued	30	11/21/2003	Method for shrinking the image of photoresist	CHEN, CHIA-CHEN	
10727590	Not Issued	30	12/05/2003	Method for converting high level motion scripts to computer animations	CHEN, CHIA-CHEN	
10796222	Not Issued	41	03/08/2004	Method for making a colorful 3D model	CHEN, CHIA-CHEN	
10834117	Not Issued	30	04/29/2004	Method of measuring the overlay accuracy of a multi-exposure process	CHEN, CHIA-CHEN	
10992049	Not Issued	30	11/18/2004	Solidified and shelled alcohols	CHEN, CHIA-CHEN	
11125213	Not Issued	30	05/10/2005	System for managing sound input/output and method for the same	CHEN, CHIA-CHEN	
11161133	Not Issued	30	07/25/2005	WIRELESS IDENTIFICATION SECURITY ACTIVATION DEVICE	CHEN, CHIA-CHENG	
11349187	Not Issued	20	02/08/2006	AND type match circuit structure for content-addressable memories	CHEN, CHIA-CHENG	
10951548	Not	30	09/27/2004	Methods and apparatus for monitoring a	CHENG, CHIA-CHENG	

	Issued		process in a plasma processing system by measuring impedance	
10952562	Not Issued	30	Methods and apparatus for monitoring a process in a plasma processing system by measuring a plasma frequency	CHENG, CHIA-CHENG

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Inventor Name Search Result

Your Search was:

Last Name = LOU

First Name = WEN-SHIOU

Application#	Patent#	Status	Date Filed	Title	Inventor Name
09794833	6480287	150		THREE DIMENSIONAL SCANNING SYSTEM	LOU, WEN-SHIOU
10620458	Not Issued	71		Method and apparatus for calibrating laser 3D digitizing	LOU, WEN-SHIOU
10623646	Not Issued	30		Method of reconstructing a regular 3D model by feature-line segmentation	LOU, WEN-SHIOU

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